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APPLICANTS

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\*\* CONTINUING DATA \*\*\*\*\*

\*\* FOREIGN APPLICATIONS \*\*\*\*\*  
 JAPAN 2002-272812 09/19/2002

IF REQUIRED, FOREIGN FILING LICENSE GRANTED  
 \*\* 12/11/2003

|   |   |                              |                         |                       |                             |
|---|---|------------------------------|-------------------------|-----------------------|-----------------------------|
| Foreign Priority claimed<br>35 USC 119 (a-d) conditions met | <input checked="" type="checkbox"/> yes <input type="checkbox"/> no<br><input checked="" type="checkbox"/> yes <input type="checkbox"/> no <input type="checkbox"/> Met after Allowance | STATE OR<br>COUNTRY<br>JAPAN | SHEETS<br>DRAWING<br>10 | TOTAL<br>CLAIMS<br>46 | INDEPENDENT<br>CLAIMS<br>18 |
| Verified and Acknowledged                                   | Examiner's Signature<br>Initials  |                              |                         |                       |                             |

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TITLE  
 Beam homogenizer and laser irradiation apparatus and method of manufacturing semiconductor device

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|------------------------------------|---|--|
| FILING FEE<br><br>RECEIVED<br>2478 | FEES: Authority has been given in Paper<br>No. _____ to charge/credit DEPOSIT ACCOUNT<br>No. _____ for following: | <input type="checkbox"/> All Fees<br><input type="checkbox"/> 1.16 Fees ( Filing )<br><input type="checkbox"/> 1.17 Fees ( Processing Ext. of time )<br><input type="checkbox"/> 1.18 Fees ( Issue ) |
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